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Atty. Dkt. 7024-499

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of: )  
)  
Said Mansour et al. )  
)  
Serial No. 09/486,301 )  
)  
I.A. Filing Date: 30 July 1999 )  
)  
LOW TEMPERATURE OXYGEN GAS SENSOR )

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231 on

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James B. Myers Jr.

Name of Registered Representative

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Signature

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Date of Signature

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INFORMATION DISCLOSURE STATEMENT

Hon. Commissioner for Patents  
Washington, D.C. 20231

Sir:

Submitted herewith on the attached Information Disclosure Citation form is a list of documents of which Applicants are aware which they believe may be material to the examination of this application, and in respect of which there may be a duty to disclose in accordance with 37 C.F.R. §1.56. Copies are not enclosed, in accordance with 37 C.F.R. §1.98(d), since they were previously cited by the Office in prior application PCT/US99/17422, which is relied upon for an earlier filing date. However, if it would assist the Examiner to have separate copies of the listed references for this application, Applicants will be happy to supply such copies upon request.

This Statement is being submitted before the first Office Action on the merits, and, therefore, it is believed that no fee is due. Should any fee be required, however, please charge such fee to Deposit Account No. 23-3030, but not to include the payment of issue fees which are or may become due.

Respectfully submitted,

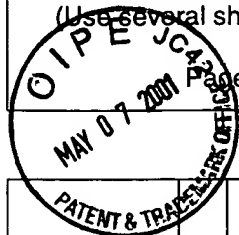
By: James B. Myers Jr.  
James B. Myers Jr., Reg. No. 42,021  
Woodard, Emhardt, Naughton  
Moriarty & McNett  
Bank One Center/Tower  
111 Monument Circle, Suite 3700  
Indianapolis, Indiana 46204-5137  
(317) 634-3456 Fax No. (317) 637-7561

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Page 1 of 2

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